

DOCKET NO: 294256US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
SHUUICHI ISHIZUKA, ET AL. : EXAMINER: MILLER, JR, J. A.  
SERIAL NO: 10/587,394 :  
FILED: JULY 27, 2006 : GROUP ART UNIT: 1792  
FOR: METHOD FOR CLEANING :  
PROCESS CHAMBER OF SUBSTRATE  
PROCESSING APPARATUS,  
SUBSTRATE PROCESSING  
APPARATUS, AND METHOD FOR  
PROCESSING SUBSTRATE

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement dated December 8, 2008, Applicants hereby elect, *without traverse*, Group I corresponding to claims 1-6 and 12-20, drawn to method. Applicants make this election based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Accordingly, examination on the merits of Group I corresponding to claims 1-6 and 12-20 is believed to be in order and an early and favorable action is respectfully requested.

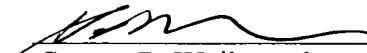
Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

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